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of separately defined areas arranged a matrix defined by [in] columns and rows [in a matrix].

Claim 9. (currently amended) The system of claim [5] 8 in which the relationship of the number (N) of separately defined areas in the rows to the number of separately defined areas (N) in the columns is rows_N = columns_N.

Claim 10. (currently amended) The system of claim [6] $\underline{8}$ in which the relationship of the number (\underline{N}) of <u>separately defined</u> areas in one column to [of] the number of <u>separately defined</u> areas in an adjacent column is areas in column = \underline{N} and areas in <u>adjacent</u> column [$\underline{N+1}$] $\underline{N+1}$ = $\underline{N+1}$.

Claim 11. (currently amended) The system of claim [6] $\underline{8}$ in which the relationship of the number (N) of <u>separately defined</u> areas in one row to of the number of <u>separately defined</u> areas in an adjacent row is areas in row_N = N and areas in adjacent row [N-1] $\underline{N-1} = N+1$.

Claim 12. (currently amended) The system of claim 1 in which the plasma sources are controlled such that the materials originating from the sources are deposited [[en-an]] upon an area of the substrate in at least one of 1) a sequential layer [[by layer]] deposition and 2) a co-deposition [[relationship]].

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Claim 13. (currently amended) [A substrate holder for the] The system of claim 8

[1 comprising] wherein the substrate comprises a side surface of a block positioned

within the central location of the chamber, the block having a multiplicity of

[longitudinally extending] cylindrical substrate elements extending from the side

surface thereof, each cylindrical substrate element individually defining a selected

area, [substrates] the cylindrical substrate elements maintained in an array of

cylindrical columns and cylindrical rows formed within [in] the block, in which [an] the

upper surfaces of the cylindrical substrate elements comprise the discrete areas [ie]

exposed to [the ions directed from] the sources.

Claim 14. (currently amended) The system [holder] of claim [11] 13 in which the

cylindrical substrate elements are [upper surface of the substrate is] inset within the

block in a matrix and a plate having a matrix of openings concentric with the matrix of

elements in the block is applied facing the surface of the block, such that the

openings in the plate are aligned with the elements and the cross-section area of an

opening in the plate [upper surface of the column in the block in which the substrate

is positioned is less than the [transverse] cross-section area of the [upper] surface of

the corresponding concentric cylindrical [substrate] element [exposed to the ions

directed from the sources].

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[RESUBMITTED CLAIMS 11, 12 AND 14 (PAGES 6 AND 7) IN RESPONSE TO THE NOTICE OF NON-COMPLIANT AMENDMENT MAILED ON JANUARY 10, 2007]

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